Applicant(s): Vaartstra et al.

Serial No. Unknown (Parent Serial No. 10/230,131)

Filed: Herewith (Parent: August 28, 2002)

For: SYSTEMS AND METHODS FOR FORMING STRONTIUM- AND/OR BARIUM-CONTAINING LAYERS

## Remarks

Please cancel claims 1-60 as requested in the Request for Filing A Continuation Patent Application Under Rule §1.53(b), filed concurrently herewith.

The new claims 61-114 are supported by the originally filed claims and the specification at, for example, page 3, line 11; and page 7, line 19 to page 8, line 10.

## Conclusion

The Examiner is invited to contact Applicants' Representatives at the below-listed telephone number, if there are any questions regarding this Preliminary Amendment or if prosecution of this application may be assisted thereby.

Respectfully submitted for

Vaartstra et al.

By

Mueting, Raasch & Gebhardt, P.A.

P.O. Box 581415

Minneapolis, MN 55458-1415

Phone: (612)305-1220 Facsimile: (612)305-1228

Customer Number 26813

April 21, 2004

y:\_\_\_\_

Loren D. Albin Reg. No. 37,763

Direct Dial (612)305-1225

"Express Mail" mailing label number EV 201890330 US

Date of Deposit: April 21 , 2004

I hereby certify that the Transmittal Letter and the paper(s) and/or fee(s), as described hereinabove, are being deposited with the United States Postal Service "Express Mail Post Office to Addressee" service under 37 C.F.R. 1.10 on the date indicated above and is addressed to the Commissioner for Patents, Mail Stop Patent Appligation, P.O. Box 1450, Alexandria, VA 22313-1450.

Name: Sava E. OLSON